

U.S. UTILITY Patent Application

SA O.I.P.E. SCANNED KC 3/2 Q.A. AA	PATENT DATE
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APPLICATION NO. 09/842403	CONT/PRIOR F	CLASS 438	SUBCLASS	ART UNIT 252 5803	EXAMINER M. Estrada
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NTS Shinichi Ito
Katsuya Okumura

Film formation method, semiconductor element and method thereof,
and method of manufacturing a disk-shaped storage medium

PTO-2040
12/89

ISSUING CLASSIFICATION

ORIGINAL					CROSS REFERENCE(S)							
CLASS		SUBCLASS			CLASS	SUBCLASS (ONE SUBCLASS PER BLOCK)						
INTERNATIONAL CLASSIFICATION												

☐ Continued on Issue Slip inside File Jacket

<input type="checkbox"/> TERMINAL DISCLAIMER	DRAWINGS		CLAIMS ALLOWED	
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims
<input type="checkbox"/> The term of this patent subsequent to _____ (date) has been disclaimed.	_____ (Assistant Examiner) (Date)		NOTICE OF ALLOWANCE MAILED	
<input type="checkbox"/> The term of this patent shall not extend beyond the expiration date of U.S. Patent No. _____	BEST AVAILABLE COPY _____ (Primary Examiner) (Date)		ISSUE FEE	
			Amount Due	Date Paid
<input type="checkbox"/> The terminal _____ months of this patent have been disclaimed.	_____ (Legal Instruments Examiner) (Date)		ISSUE BATCH NUMBER	

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